

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

Docket Number (Optional)

123029-1015

Application Number

Unknown

Applicant(s)

Wei-Kan Chu, et al.

Filing Date

July 17, 2003

Group Art Unit

Unknown

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
TMT		5,169,798	12/8/92	Eaglesham et al.	437	81	6/28/90
TMT		6,362,081 B1	3/26/02	Chuang	438	522	7/7/00

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

TMT		Lin Shao et al. " Stability Studies of Ultra-Shallow Junction Formed by Low Energy Boron Implant and Spike Annealing". J. Appl. Phys.Vol. 92, No. 10, pp. 5788-5792 (2002).
TMT		P.E. Thompson and J. Bennet, "Formation and Thermal Stability of Ultra-Shallow p+ Junctions in Si and Si1-xGex Formed By Molecular Beam Epitaxy", J. Appl. Phys.Vol. 92, No. 11, 6845-6850 (2002).

EXAMINER

T. M. Thomas

DATE CONSIDERED

12-23-03

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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TMT		Alette Mouroux, et al., "Phase Formation and Resistivity In The Ternary System Ti-Nb-Si", J. Appl. Phys. Vol. 86, No. 4, 2323-2329, (1999).			
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